IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yeo, et al. Docket No.: TSM03-0926

Serial No.: 10/685,938 Art Unit: 2891

Filed: October 15, 2003 Examiner: Movva, Amar

For: Dummy Pattern for Silicide Gate Electrode

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR § 1.116

Dear Sir:

Applicants respectfully submit the following remarks in response to Examiner's Office Action dated May 13, 2008, which Action is made final. Applicants respectfully request that these remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of the claims.

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